## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kawata

Application No. New Application

Filed: July 17, 2003

For: SCATTERING-RETICLE ASSEMBLIES FOR

ELECTRON-BEAM MICROLITHOGRAPHY INCLUDING A SCATTERING-STENCIL RETICLE PORTION AND A SCATTERING-

MEMBRANE RETICLE PORTION

Examiner: Not yet assigned

Date: July 17, 2003

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450 Art Unit: Unknown

## **CERTIFICATE OF MAILING**

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on July 17, 2003, as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-14501.

Attorney for Applicant

## PRELIMINARY AMENDMENT

Before commencing substantive examination of this application, please amend the application as follows: